



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re the Application of: **IMAI, Genji**

Group Art Unit: **1752**

Serial No.: **09/976,279**

Examiner: **Yvette C. Thornton**

Filed: **October 15, 2001**

P.T.O. Confirmation No.: **1120**

For: **NEGATIVE PHOTOSENSITIVE RESIN COMPOSITION, NEGATIVE PHOTOSENSITIVE DRY FILM AND METHOD OF FORMING PATTERN**

RESPONSE UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 16, 2003

Sir:

In response to the Office Action dated **July 16, 2003**, extended to **December 16, 2003**, by a two-month Petition for Extension of Time, the following remarks are respectfully submitted.